



Docket No. 2003-0372 / 24061.93  
Customer No. 42717

IFW

Applicant: Chiu-Chien Yuan, et al.

Serial No.: 10/821,016

Filed: April 8, 2004

For: Method for Circulating a Report in a  
Semiconductor Manufacturing  
Environment

§ Docket No.: 2003-0372 / 24061.93  
§  
§ Examiner: To Be Determined  
§  
§ Art Unit: To Be Determined  
§  
§ Conf. No.: 9310  
§  
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**SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT**

Mail Stop Amendments  
Commissioner For Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In compliance with the duty of disclosure under 37 CFR §1.56, and in accordance with the practice under 37 CFR §1.97 and §1.98, the Examiner's attention is directed to the documents listed on the enclosed modified Form PTO-1449. No inference should be made that the cited references are in fact material, are in fact prior art, or that no better art exists. The cited patents are listed in numerical order and are not in any order based on their pertinence.

This Information Disclosure Statement is being filed within three months of the United States filing date or before the mailing date of a first Office Action on the merits. No certification or fee is required (37 CFR §1.97(b)).

It is respectfully requested that the above information be considered by the Examiner and that a copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered.

Respectfully submitted,

David M. O'Dell  
Registration No. 42,044

Date: 10-11-04

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**Certificate of Mailing**

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to M/S Amendment, Commissioner For Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on the date indicated below.

Bonnie Boyle  
Name

10-11-04

